



# ***Development of X-Ray Mirror Segments for the Constellation-X Mission***

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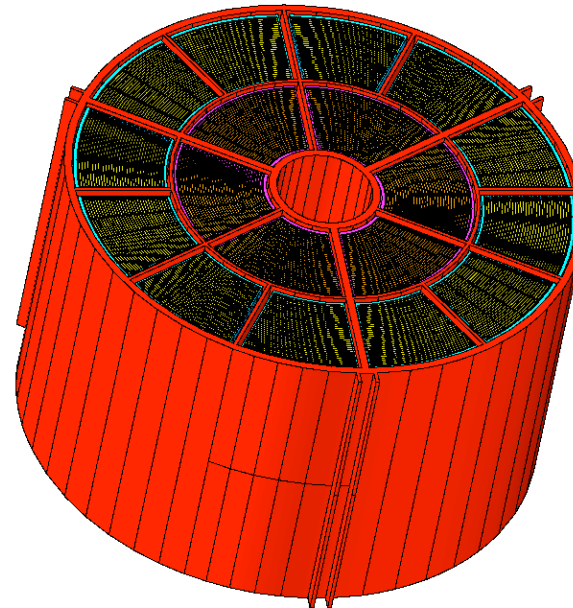
**Bill Davis and Bill Podgorski**

**Smithsonian Astrophysical Observatory**



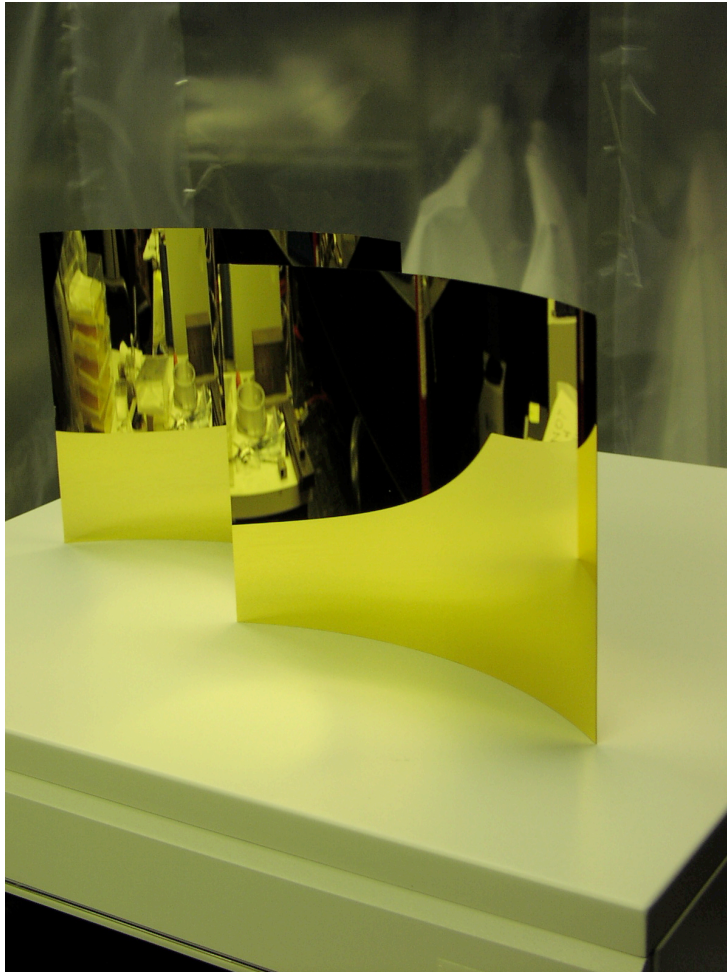
## Constellation-X Spectroscopic X-ray Telescopes (SXT)

- **Total Number of Mirror Assemblies: 4**
- **Total Effective Photon Collection Area at 1 keV:  $3 \text{ m}^2$  or  $0.75 \text{ m}^2$  for each mirror assembly**
- **Angular Resolution: 15" HPD at observatory level; 12" for the mirror assembly; 10" for mirror segments**
- **Total Physical Mirror Area:  $\sim 1000 \text{ m}^2$**
- **Baseline Design: Each mirror assembly**
  - 1.6m in diameter
  - 10m focal length
  - 230 nested shells, each shell segmented into 6 (inner) or 12 (outer) segments
  - $\sim 4,000$  mirror segments
  - Smallest segment: 20cm by 20cm
  - Largest segment: 20cm by 40cm





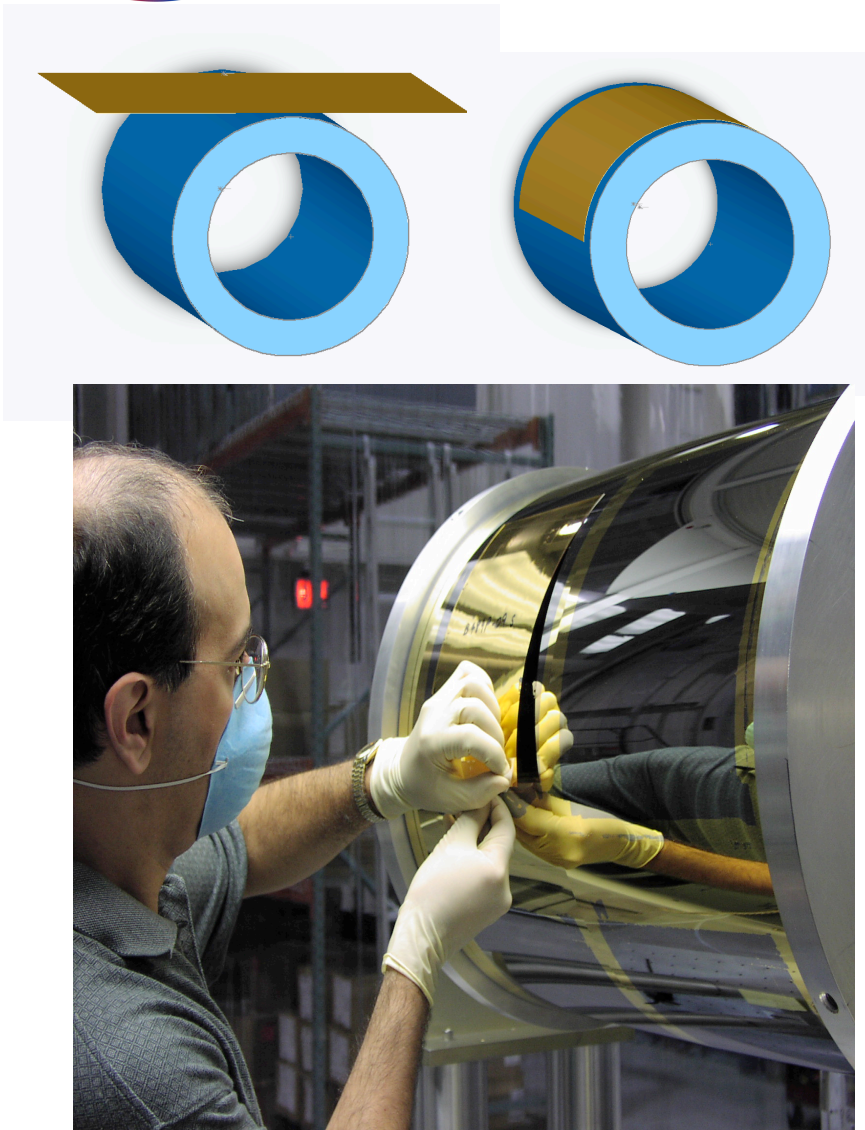
## Mirror Segment Requirements



- *Mass: Mirror segments can only be about 0.4mm in thickness (using borosilicate glass), corresponding to an areal density of **1 kg/m<sup>2</sup>***
- *Figure:*
  - *Sag (2nd order peak to valley) must be within 0.2 $\mu$ m of the theoretical value*
  - *After removing the sag, the residual axial slope error must be < 2" rms*
  - *Microroughness must be ~6Å rms (0 to 0.3mm length scale)*



## Technical Approach

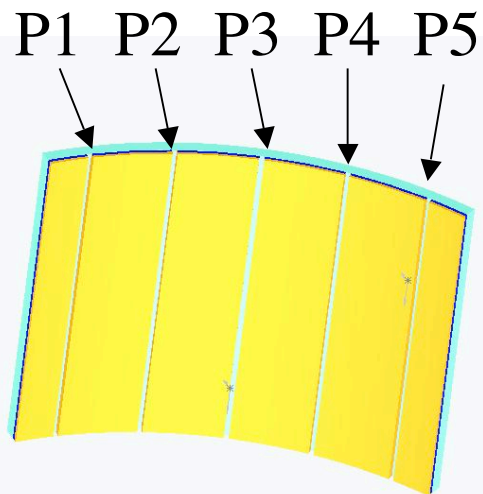


- **Create a substrate by slumping a flat glass sheet onto a forming mandrel. This substrate provides the overall figure for the mirror segment**
- **Eliminate high frequency errors of the substrate using an epoxy replication**



## Preliminaries

**Five axial figure scans  
using a Wyko  
interferrometer analyzed in  
both spatial and frequency  
domains**



$$\sigma^2 = \int psd(f) \cdot df$$

$$\sigma^2 = 4\sigma^2 \int psd(f) \cdot f^2 \cdot df$$

$$\sigma^2 = \frac{4\sigma^2}{\log_{10}(e)} \int psd(f) \cdot f^3 d[\log_{10}(f)]$$

*Define Modified PSD as*

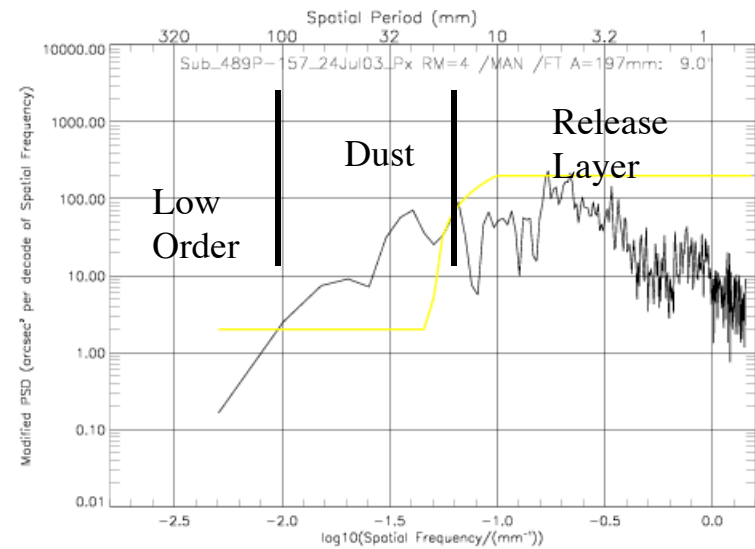
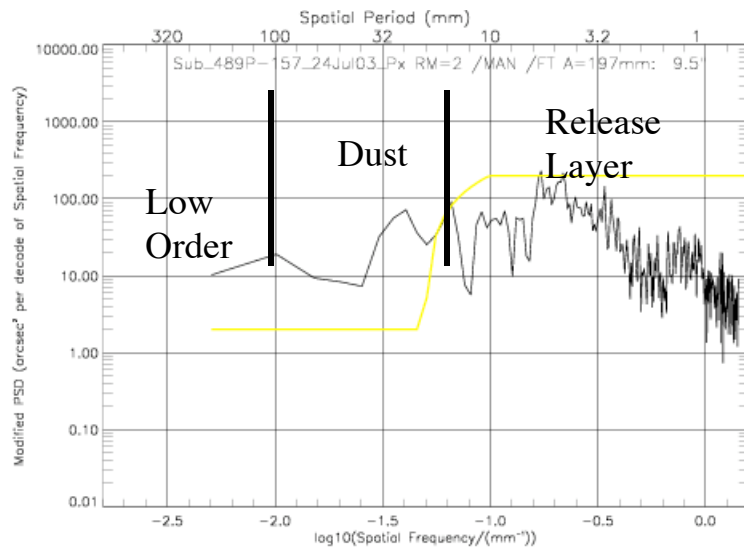
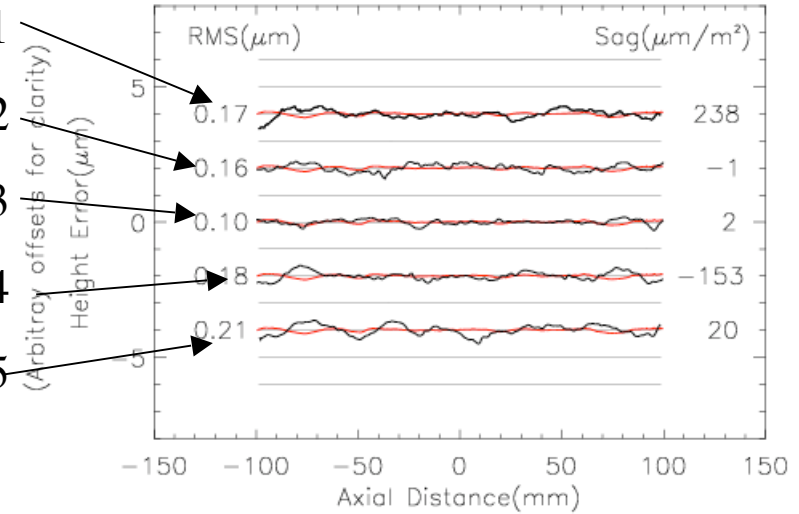
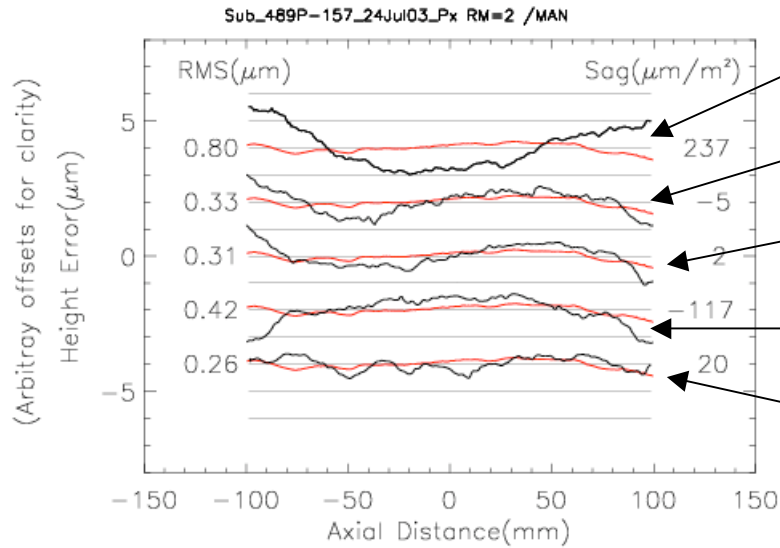
$$\frac{d\sigma^2}{d[\log_{10}(f)]} = \frac{4\sigma^2}{\log_{10}(e)} \cdot psd(f) \cdot f^3$$



# A Typical Primary Substrate

Only tilt (1st order, tilt) removed

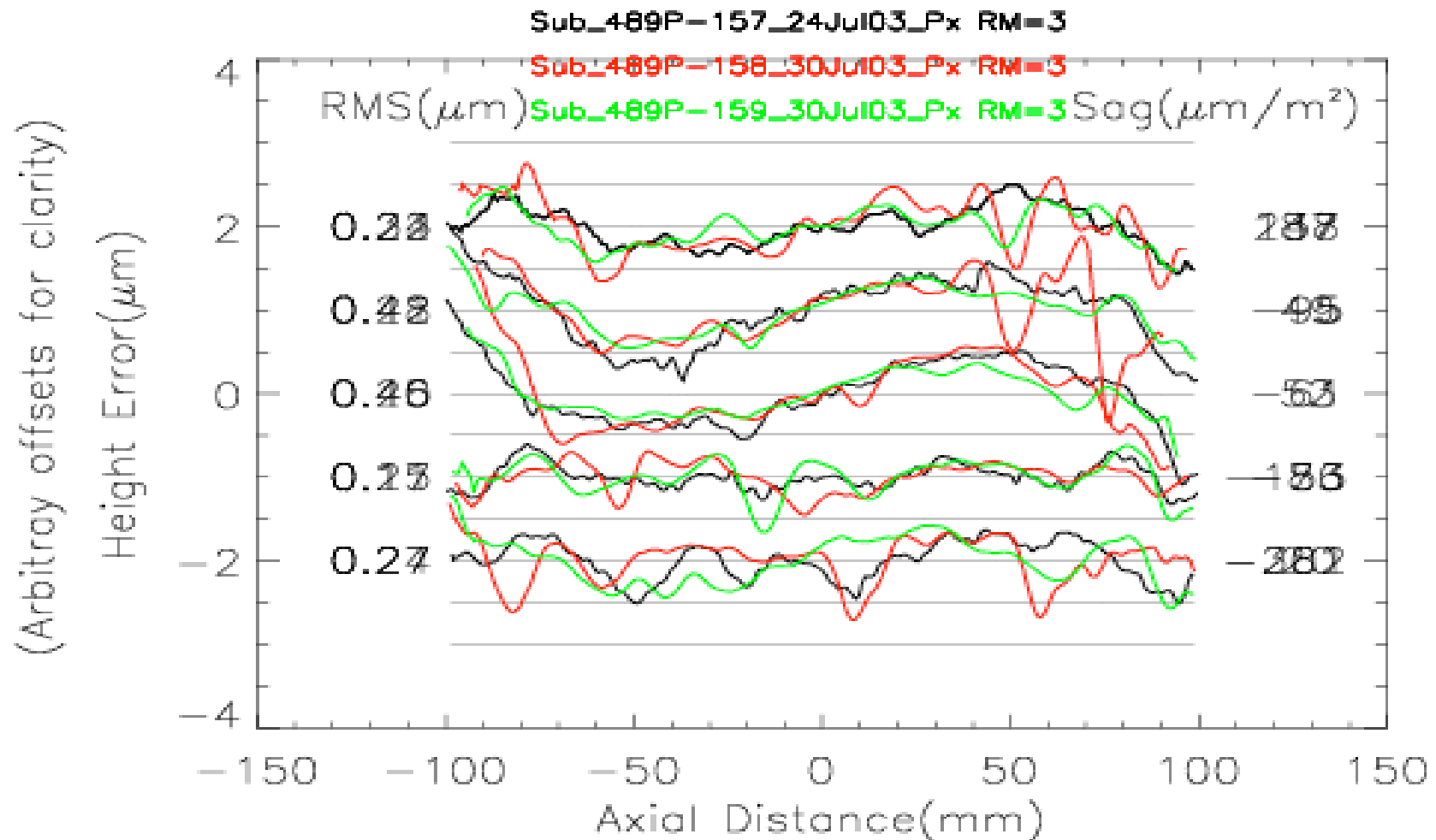
1st, 2nd, and 3rd orders removed





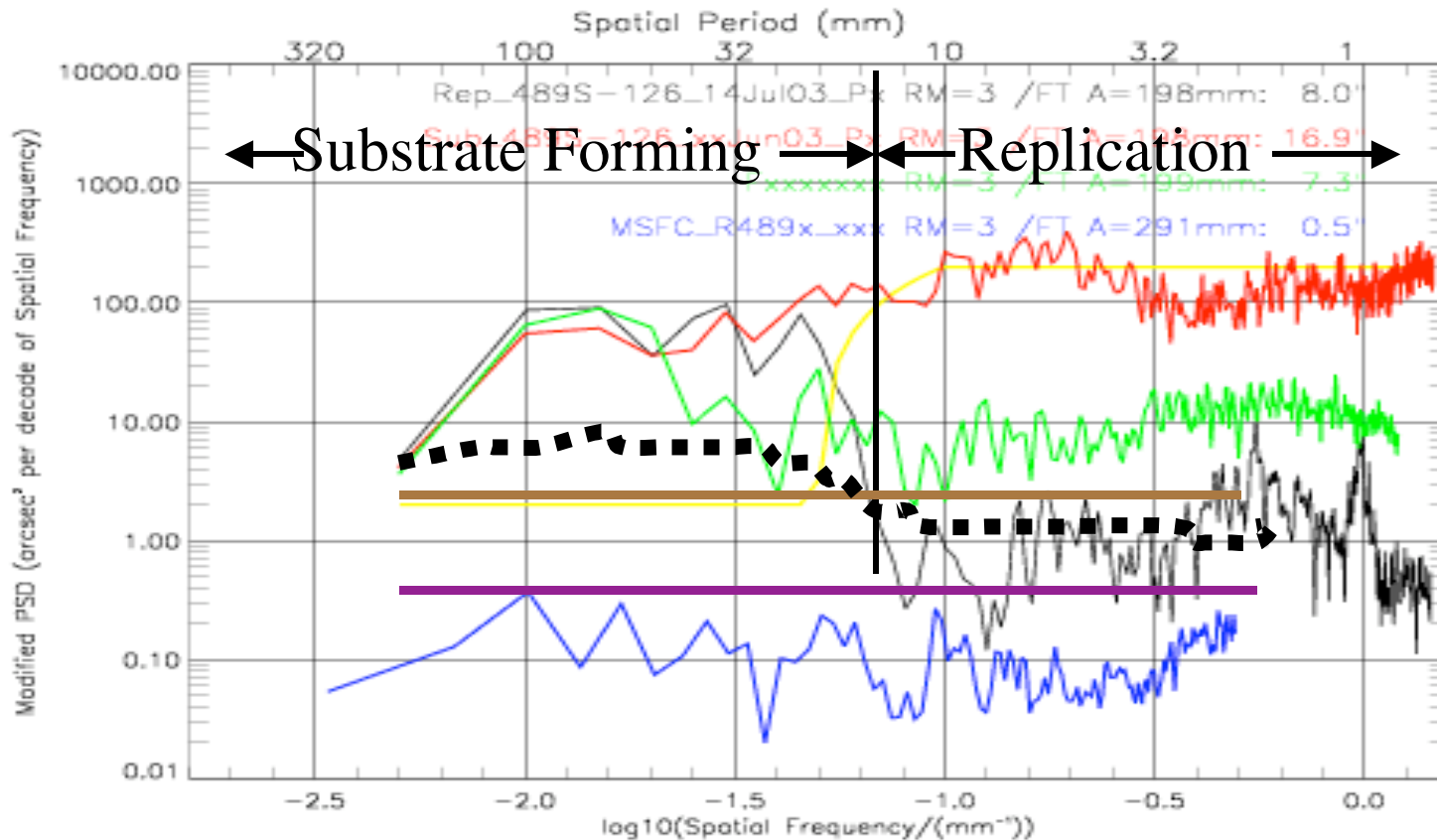


## Three Consecutively Formed Substrates





## A Typical Substrate and Replica



- Red: substrate;
- Black: replica;
- Green: forming mandrel;
- Blue: Zeiss replication mandrel;

- Yellow: substrate requirement;
- Brown: Corresponding to a 12" HPD (Con-X Requirement)
- Purple: Corresponding to a 5" HPD (Con-X Goal)





## Status and Outlook

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### □ **Forming and Replication Mandrels**

- *Three 4" HPD segment replication mandrels have been fabricated and delivered by Zeiss*
- *Matching 4" HPD forming mandrels are on order and are being fabricated by Schott and Zeiss*

### □ **Substrate Forming**

- *Correcting low order errors (Forming Mandrel Distortion, Error due to Distortion caused by gravity and other forces during measurements)*
- *Correcting middle order errors (Cleaning up the forming environment)*

### □ **Replication (correcting high frequency error of substrate)**

- *Using 5 to 10-um epoxy thickness*
- *Using slow and gentle cure cycles to reduce epoxy*

**We expect to meet, and possibly exceed, Constellation-X requirements within a year**